

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akitaka KIMURA

Appln. No.: 09/161,981

Group Art Unit: 2881

Filed: September 29, 1998

Examiner: J. Davie

For: SEMICONDUCTOR LAYER FORMED
BY SELECTIVE DEPOSITION AND
METHOD FOR DEPOSITING
SEMICONDUCTOR LAYER

#16/Ext. of
Time
T. Young
1-23-01

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of October 10, 2000 to December 11, 2000 (the first business day following the one-month extended date of December 10, 2000).

The statutory fee is \$110.00. Please charge Deposit Account No. 19-4880 in the amount of this fee. Please charge any additional fees under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

Respectfully submitted,



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Date: January 12, 2001

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